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Interference of Spherical Wave of Thermal Radiation Emitted by a Film System

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Abstract

This paper deals with the interference of spherical waves of thermal radiation emitted by a surface film system which consists of a metal substrate and a semi-transparent film. A spectroscopic experiment is made to reconfirm the clear interference in emission spectra of the film system. We present a theoretical model in which an electromagnetic theory for a spherical wave is combined with Planck's theory of thermal radiation. The mechanism of interference of spherical waves is discussed, and it is suggested that thermal radiation waves emitted by a number of dipoles of the metal might be coherent among each other.

Key words : thermal radiation, emission, spherical wave, interference, coherency, surface film, spectroscopic measurement

Nomenclature

d	:	(average) thickness of film, m
$\hat{\mathbf{E}}(\mathbf{r})$:	complex electric field vector at position \mathbf{r} , V/m
\mathbf{E}_O	:	(real) electric field vector at position \mathbf{r}_O , V/m
\mathbf{e}_q	:	unit vector in direction of q-polarized component of electromagnetic wave
i	:	imaginary unit
I_B	:	(spectral) intensity of blackbody radiation in vacuum, W/(m ³ ·sr)
k	:	index of absorption, (imaginary part of \hat{n})
k	:	wavenumber of electromagnetic wave in vacuum, m ⁻¹
$\hat{\mathbf{k}}$:	complex wavenumber vector of electromagnetic wave, ($=\mathbf{k}_{\text{real}}+i\mathbf{k}_{\text{imag}}$), m ⁻¹
$\mathbf{k}_{\text{real}}, \mathbf{k}_{\text{imag}}$:	real and imaginary parts of complex vector $\hat{\mathbf{k}}$, respectively, m ⁻¹
n	:	index of refraction
\hat{n}	:	optical constant, ($=n+ik$)
R	:	(spectral directional-incidence specular reflection energy) reflectance
\mathbf{r}	:	position vector of point in medium 1, m
\mathbf{r}'	:	position vector of point on interface I, m
\hat{r}	:	Fresnel's complex reflection coefficient
\mathbf{r}_O	:	position vector of point on hemisphere centered at point O in medium 1, m
$\langle \mathbf{S} \rangle$:	time mean of Poynting vector of electromagnetic wave, W/m ²
t	:	time, s
\hat{t}	:	Fresnel's complex transmission coefficient
ΔA_O	:	infinitesimal area in vicinity of position \mathbf{r}_O , m ²
ΔA_1	:	infinitesimal area in vicinity of point O, (=const.), m ²
$\Delta A'$:	infinitesimal area in vicinity of position \mathbf{r}' , (=const.), m ²
ΔQ_{qOI}	:	energy of electromagnetic wave passing through area ΔA_O , W

- $\Delta Q_{(s+p)0}$: energy of electromagnetic wave passing through area ΔA , W
- $\Delta \Omega_0$: solid angle of observation, ($=\Delta \Omega_{00}$), sr
- $\Delta \Omega_{0I}$: solid angle of electromagnetic wave transmitted through interface I, sr
- $\Delta \Omega_{I0}$: solid angle of electromagnetic wave incident on interface I, sr
- ε : (spectral directional) emittance
- θ_0 : emission angle of electromagnetic wave in medium 0, (angle of observation),
($=\theta_{00}$), rad
- θ_1 : emission angle of electromagnetic wave in medium 1, ($=\theta_{10}$), rad
- λ : wavelength of electromagnetic wave in vacuum, m
- μ : absolute magnetic permeability of vacuum, H/m
- σ : rms roughness, m
- ω : angular frequency of electromagnetic wave, rad/s

Subscripts

- B : blackbody
- film : film system
- l : number of multiple reflection in film, ($l=0, 1, 2, \dots$)
- N : 15°-direction emission
- NH : 15°- incidence hemispherical reflection
- NN : 15°- incidence specular reflection
- O : centered at point O
- q : q-polarized components of electromagnetic wave, (q=s, p)
- real, imag : real and imaginary parts of complex quantity, respectively
- s, p : s- and p-polarized components of electromagnetic wave, respectively
- (s+p) : natural radiation
- 0, 1, 2 : medium 0 (vacuum), medium 1 (film), medium2 (substrate), respectively

Superscripts and others

calc : calculated

exp : experimental

\wedge : complex quantity

$\| \quad \|$: norm of complex quantity

1. Introduction

Thermal radiation characteristics of a metal or a semi-conductor can change sensitively when a film and/or microstructure is formed on the surface. The authors [1] found that the spectra of thermal radiation emitted by a metal surface, on which a semi-transparent film is formed, show a clear phenomenon of radiation interference. The interference phenomenon in the emission spectra was impressive for us [2], but it was not a new finding. The phenomenon in such a film system had been well known empirically in the field of metallurgy [3]. However, the interference in thermally emitted radiation spectra has not been explained theoretically.

The film interference in the reflection of a plane electromagnetic wave has been well known, and has been explained enough by classical electromagnetic wave theory. On the other hand, interference of a thermally emitted radiation wave cannot be explained in a similar manner. That is, thermal radiation is spherical electromagnetic waves emitted by a number of dipoles thermally moving randomly. The spherical waves emitted by a number of neighboring dipoles have been assumed not to interfere systematically among each other. For the spherical wave to be characterized by a clear interference phenomenon, a spherical wave emitted by an individual dipole and the components of the wave multiply reflected in the film, should interfere systematically in the vicinity of the dipole. Intensity of a spherical wave attenuates in the film inversely proportional to the square of the distance from the radiation source. These conditions are different from the interference of a reflected plane wave. Kirchhoff's law which does not consider the phase of an electromagnetic wave is outside of this consideration on this interference phenomenon.

For the quantitative evaluation of the emission flux or emittance spectrum for thermal radiation, Maxwell's electromagnetic wave theory is not enough. Planck's theory of thermal radiation should be combined with the Maxwell's theory for characterizing the intensity of the emitted thermal radiation. Such a combined theoretical description has not been presented. A

theoretical model should be presented here on the coherency of a spherical electromagnetic wave in the vicinity of radiation sources with consideration of Planck's theory.

In the thermal engineering field, thermo-photo-voltaic (TPV) conversion techniques are required, and a spectrally functional radiation emitter which emits thermal radiation in a specified wavelength band region selectively is expected to be developed [4]. The above-mentioned surface film system is promising from this engineering point of view.

In the present study, we deal with the interference of thermal radiation emitted by a film system which consists of a metal substrate and a semi-transparent film. First, a spectroscopic experiment is made on the emission and reflection of this film system. Next, a theoretical model of radiation emission is presented by combining electromagnetic theory for a spherical wave with Planck's theory of thermal radiation. The spectra calculated on the model are compared with the measured spectra to consider the mechanism of the interference of thermally emitted radiation waves. It is suggested that thermal radiation waves emitted by a number of dipoles of the metal might be coherent among each other. Also, the possibility of an effective spectrally functional radiation emitter is suggested.

2. Procedure and Results of Spectroscopic Experiment

2.1 Preparation and formation of film system

Material of the specimen of a film system is a polycrystalline nickel plate of 99.99 % in chemical purity, whose size is 15 mm in width, 50mm in length and 2 mm in thickness. The surface is mechanically buffed to realize the optical smoothness of the maximum roughness less than 30 nm. The surface is heated in atmospheric air at a heating rate of 1 K/s. An oxide film is formed on the nickel surface. The surface is heated up to 1100 K, and heating is stopped. The surface is cooled naturally to room temperature, and the surface state of 1100 K is frozen.

2.2 Spectra in formation process of film system

In this film formation process, we measure the change of spectra of 15°-incidence specular reflectance R_{NN} and 15°-direction emittance ε_N of the surface simultaneously by a high-speed spectrophotometer system [1]. Figure 1 shows the results. The abscissa λ of the figure is the wavelength of radiation in vacuum. t is the time after the start of heating of the surface. At $t=600\sim 800$ s the surface reaches the temperature of 900~1100 K. A surface film grows well at this stage. Corresponding to this film growth clear oscillation appears in the spectra of R_{NN} and ε_N . With the growth of the film valleys and hills of the spectrum, oscillations appear and shift to the longer wavelength region of the spectra.

2.3 Spectra of film system at 1100 K

In Figure 1, $t=800$ s corresponds to the time when heating of the surface is stopped and the surface is begun to be cooled. In the discussion on Figure 5 in Section 4, measured values of reflectance and emittance at the last stage of this heating ($t=800$ s) are noted by $R_{NN}^{\text{exp}}(1100 \text{ K})$ and $\varepsilon_N^{\text{exp}}(1100 \text{ K})$, respectively. The R_{NN} spectrum at this stage is analyzed by a spectrum surface diagnosis technique of Reference [5]. The average thickness d of the formed film is $d=0.9 \text{ }\mu\text{m}$. The rms roughness σ of the film surface cooled to room temperature is $\sigma=0.2 \text{ }\mu\text{m}$, which is measured by an optical microscope.

2.4 Spectra of film system at 600 K

The surface system once cooled to room temperature is heated up to 600 K and kept at the temperature. Spectra of 15°-incidence specular reflectance R_{NN} and 15°-direction emittance ε_N are measured simultaneously by a Fourier transformation infrared spectrophotometer system [6]. This spectrophotometer was specially designed to measure the reflectance and emittance simultaneously. It takes longer time for the spectrum measurement than that by the high-speed spectrophotometer system [1], and it does not fit for the fast

measurement of the surface in a transient process. On the other hand this FTIR system has higher sensitivity and it measures comparatively weak emission of a surface at temperatures of 600 K level. Also, it can measure the spectra of R_{NN} and emittance ε_N over the wavelength region of $\lambda = 1.5 \sim 16 \mu\text{m}$. Since the surface film system is known to be stable in atmospheric air at less than 700 K, the measurement is made at 600 K. The spectra of R_{NN} and ε_N measured in this experiment are noted as $R_{NN}^{\text{exp}}(600 \text{ K})$ and $\varepsilon_N^{\text{exp}}(600 \text{ K})$.

2.5 Results of spectroscopic measurement

Figure 5 as described later in Section 4.1 shows the results of the spectra of reflectance $R_{NN}^{\text{exp}}(1100 \text{ K})$ and $R_{NN}^{\text{exp}}(600 \text{ K})$ and, emittance $\varepsilon_N^{\text{exp}}(1100 \text{ K})$ and $\varepsilon_N^{\text{exp}}(600 \text{ K})$. The reflectance is that for natural radiation, and the emittance is that for emitted natural or unpolarized radiation.

2.5.1 Experimental errors and surface scattering Measured reflectance $R_{NN}^{\text{exp}}(600 \text{ K})$ is as high as 1 in the longer wavelength region of $\lambda > 10 \mu\text{m}$. It is considered to be caused by a background radiation error. Reflectance R_{NN} is low in the shorter wavelength region. It is caused mainly by the influence of the surface roughness. The surface is roughened in the process of oxide film growth. Reflected radiation is scattered over hemisphere. The reflectance R_{NN} is a directional reflectance for the specular reflection component. Thus, reflectance R_{NN} decreases particularly in the shorter wavelength region.

2.5.2 Interference of radiation in emittance spectra In Figures 1 and 5 clear oscillation of interference of film interference is found not only in the spectra of reflectance but in those of emittance. Interference behavior in the emitted thermal radiation [1, 2, 5] is reconfirmed experimentally.

2.5.3 Stability of surface state The spectra of reflectance $R_{NN}^{\text{exp}}(600 \text{ K})$ and $R_{NN}^{\text{exp}}(1100 \text{ K})$, and the spectra of emittance of $\varepsilon_N^{\text{exp}}(600 \text{ K})$ and $\varepsilon_N^{\text{exp}}(1100 \text{ K})$ are near, respectively, to each other. Slight deviation of the wavelengths of interference in the four kinds of spectra is not due to the change in the surface state but due to the deviation of the

wavelength correction of the two spectrophotometer systems employed. The spectrum of $\varepsilon_N^{\text{exp}}(600 \text{ K})$ is presumed to be near to that of $\varepsilon_N^{\text{exp}}(1100 \text{ K})$ even in the shorter wavelength region where the emittance could not be measured at 600 K.

2.5.4 Complementary relationship of reflectance and emittance In the measured spectra of reflectance and emittance, wavelengths of hills and valleys in the spectra of emittance $\varepsilon_N^{\text{exp}}$ and those of valleys and hills in the spectra of reflectance $R_{\text{NN}}^{\text{exp}}$ are near to each other. With respect to the absolute values of reflectance R_N and emittance ε_N , a complementary relationship of $R_{\text{NN}} + \varepsilon_N = 1$ seems to hold in the longer wavelength region of $\lambda > 5 \text{ } \mu\text{m}$ where the influence of surface scattering is weak. In this case, the directional reflectance R_{NN} is substantially equal to the 15° -incident hemispherical reflectance R_{NH} , and the complementary relationship of $R_{\text{NH}} + \varepsilon_N = 1$ holds in this wavelength region.

If we would make a simultaneous measurement of the hemispherical reflectance R_{NH} and emittance ε_N , then we might be able to have an experimental result in which the complementary relationship of $R_{\text{NH}} + \varepsilon_N = 1$ holds over the entire wavelength region including the wavelengths of strong surface scattering and interference oscillation. This relationship is formally the same as that of Kirchhoff's law. But, the law holds for the system in the thermal equilibrium and does not consider anything on the phase of the electromagnetic wave.

3. Theoretical Modeling of Radiation Emission of Film System

3.1 Theory of thermal radiation emission

Thermal radiation consists of spherical electromagnetic waves emitted by a number of dipoles. An electromagnetic wave emitted by a dipole is assumed to be incoherent to another electromagnetic wave emitted by another dipole (Figure 2). On the basis of this assumption, we present a theoretical model of an interfered electromagnetic wave of thermal radiation emitted by a film system. Behavior of an electromagnetic wave in a film system is formulated

combining Planck's theory of thermal radiation, and we enable the description of an interfered emittance spectrum of thermal radiation of a surface film system.

3.2 Model of radiation emission of film system

Figure 3 explains the physical model of a film system. The film system consists of a single layer of a parallel film of thickness d (medium 1) on a substrate (medium 2). The film system faces vacuum space (medium 0). The substrate is a strongly absorbing medium of radiation considered. The film is weakly absorbing and semi-transparent for radiation, but the self-emission is negligibly weak. The weak absorption does not affect the surface/interface reflection and transmission of the electromagnetic wave, and the reflection and transmission angles in the film can be dealt as real quantities. The interfaces I and II are assumed to be optically flat and smooth. A spherical electromagnetic wave is emitted to medium 1 by an infinitesimal area ΔA_1 which includes a dipole at point O on interface II and in the medium 2 side. The spherical wave experiences l times ($l=0, 1, 2, \dots$) of multiple reflection in the film of medium 1 (abbreviated in Figure 3), and is transmitted by interface I. The electric field of the l -th order interference wave is formed in an infinitesimal area $\Delta A'$ in the vicinity of position \mathbf{r}' on interface I and in the medium 0 side. We observe this field at an observation point P far from the film system. In the calculation of emission we follow the electric field of the spherical wave which is described by complex vector quantities, and evaluate the observed energy.

3.3 Formulation of radiation emission wave of film system

3.3.1 s- and p-components First, we determine a coordinate system in which the origin is set at a representative point O of the position of a dipole, the emission source of radiation. A plane including a unit vector \mathbf{N} on point O normal to interface II and a position \mathbf{r}' on interface I is named the emission plane (Figure 3). The spherical wave emitted at point O is divided into two polarization components. The component oscillating perpendicularly to

the emission plane is named s-component, and the component oscillating parallel to the emission plane is named p-component. These two components, s-component and p-component, are represented by a subscript q (=s, p) in the following. The magnitude and direction of the q-component vector of the electric field depend on l of the l -th order wave of the multiple reflection of the emitted radiation in the film system.

3.3.2 Electric field of spherical wave in film A spherical wave is emitted at point O on interface II to medium 1. The q-component $\hat{E}_{q1}(\mathbf{r})$ of the complex electric field vector of the spherical wave is described at position \mathbf{r} in medium 1, when the wave has not experienced the first reflection, by,

$$\begin{aligned}\hat{E}_{q1}(\mathbf{r}) &= \frac{2\pi}{(\mathbf{k}_{1, \text{real}} \cdot \mathbf{r}) \exp(-\mathbf{k}_{1, \text{imag}} \cdot \mathbf{r}_0)} E_{q0} \exp(i \hat{\mathbf{k}}_1 \cdot \mathbf{r}) \\ &= \frac{2\pi}{k n_1 r \exp(-k k_1 r_0)} E_{q0} \exp(i k n_1 r) \exp(-k k_1 r)\end{aligned}\quad (1)$$

where,

$$r = |\mathbf{r}| \quad (2)$$

The complex wavenumber vector $\hat{\mathbf{k}}_1$ of the spherical wave in medium 1 is described by,

$$\begin{aligned}\hat{\mathbf{k}}_1 &= \mathbf{k}_{1, \text{real}} + i \mathbf{k}_{1, \text{imag}} \\ &= k \hat{n}_1 \mathbf{r} / |\mathbf{r}|\end{aligned}\quad (3)$$

In the case of this spherical wave, vectors $\mathbf{k}_{1, \text{real}}$ and $\mathbf{k}_{1, \text{imag}}$, the real and imaginary parts of the complex vector $\hat{\mathbf{k}}_1$, are of the same direction. \hat{n}_1 is the optical constant of medium 1, k and λ are wavenumber and wavelength of the electromagnetic wave in vacuum, respectively,

$$\hat{n}_1 = n_1 + i k_1 \quad (4)$$

$$k = 2\pi / \lambda \quad (5)$$

Electric field E_{q0} ,

$$E_{q0} = \hat{E}_{q1}(\mathbf{r}_0) \quad (6)$$

is that at position \mathbf{r}_0 on a hemisphere centered at point O and of radius,

$$|\mathbf{r}_0| = r_0 = 2\pi / (k n_1) = \lambda / n_1 \quad (7)$$

3.3.3 Electric field of multiply interfered wave at film surface The q-component

of the complex electric field vector $\hat{E}_{q0l}(\mathbf{r}')$ of the l -th wave of the spherical wave, which is emitted at point O, has experienced l times of multiple reflection in the film, and was transmitted by the interface I to the position \mathbf{r}' on interface I in the medium 0 side, is described by,

$$\hat{E}_{q0l}(\mathbf{r}') = \frac{2\pi}{(\mathbf{k}_{1, \text{real}, l} \cdot \mathbf{r}_l') \exp(-\mathbf{k}_{1, \text{imag}, l} \cdot \mathbf{r}_{0l})} E_{q0l} \exp(i \mathbf{k}_{1l} \cdot \mathbf{r}_l') \cdot (\hat{r}_{q10l})^l (\hat{r}_{q12l})^l (\hat{t}_{q10l})^l \quad (8)$$

where,

$$\mathbf{r}_l' = \mathbf{r}' + 2ld\mathbf{N} \quad (9)$$

$$\mathbf{N} = (0, 0, 1) \quad (10)$$

$$\begin{aligned} \hat{\mathbf{k}}_{1l} &= \mathbf{k}_{1, \text{real}, l} + i\mathbf{k}_{1, \text{imag}, l} \\ &= k \hat{n}_1 \mathbf{r}_l' / |\mathbf{r}_l'| \end{aligned} \quad (11)$$

$$r_l' = |\mathbf{r}_l'| \quad (12)$$

The electric field E_{q0l} in Eq. (8) characterizes the spherical wave emitted from the infinitesimal area ΔA_1 in the vicinity of point O in medium 2 to medium 1 in the direction corresponding to l . It is described by,

$$\mathbf{E}_{q0l} = |\mathbf{E}_{q0l}| \mathbf{e}_{ql} \quad (12)$$

where \mathbf{e}_{ql} is the (non-dimensional) unit vector in the direction of q-polarization component.

The unit vector \mathbf{e}_{ql} is defined by the following equations.

$$\mathbf{e}_{sl} = (0, 1, 0) \quad (13)$$

$$\mathbf{e}_{pl} = \mathbf{e}_{sl} \times \mathbf{r}_l' / |\mathbf{e}_{sl} \times \mathbf{r}_l'| \quad (14)$$

The standard field intensity $|\mathbf{E}_{q0l}|$ of the wave is given in Eq. (22) through discussion in Section 3.3.4. In Eq. (8) \hat{r}_{qijl} and \hat{t}_{qijl} are Fresnel's complex reflection coefficient and transmission coefficient, respectively, in the case when the q-polarization component of the l -th order wave propagates to interface of medium i and medium j from the medium i side. The coefficients are calculated depending on \mathbf{r}_l' . The complex electric field vector $\hat{E}_{q0}(\mathbf{r}')$ of the q-polarization component of superimposed/interfered wave at position \mathbf{r}' on interface I

and in the medium 0 side, is described by,

$$\hat{E}_{q0}(\mathbf{r}') = \frac{2\pi}{\exp(-\mathbf{k}_{1,\text{imag}} \cdot \mathbf{r}_O)} \Sigma_l \mathbf{E}_{qOl} \hat{g}_{ql} \quad (15)$$

where,

$$\hat{g}_{ql} = \frac{\exp(i\hat{\mathbf{k}}_{1l} \cdot \mathbf{r}')}{\mathbf{k}_{1,\text{real},l} \cdot \mathbf{r}'} (\hat{r}_{q10l})^l (\hat{r}_{q12l})^l (\hat{t}_{q10l}) \quad (16)$$

Since the inner product $(\mathbf{k}_{1,\text{imag}}, \mathbf{r}_O)$ in the exponential term in the right hand side of Eq. (8) does not depend on l , it is written in Eq. (15) by,

$$\mathbf{k}_{1,\text{imag}}, \mathbf{r}_O = \mathbf{k}_{1,\text{imag}} \cdot \mathbf{r}_O \quad (17)$$

The complex electric field vector $\hat{E}_0(\mathbf{r}')$ for the emission of natural radiation which consists of s- and p-polarized components equivalently is written by,

$$\hat{E}_0(\mathbf{r}') = \frac{2\pi}{\exp(-\mathbf{k}_{1,\text{imag}} \cdot \mathbf{r}_O)} \Sigma_q [\Sigma_l \mathbf{E}_{qOl} \hat{g}_{ql}] \quad (18)$$

3.3.4 Standard intensity of spherical wave in film

We evaluate the energy ΔQ_{qOl}

(unit: W) of the spherical wave which passes an infinitesimal area ΔA_{Ol} on a hemisphere centered at position \mathbf{r}_O and of radius $|\mathbf{r}_O| = r_O (< 2d/\cos\theta_{1l})$ before the wave experiences the first reflection. The angle θ_{1l} is the emission angle in medium 1 in the case when the wave has experienced l times of multiple reflection in the film. Absorption in medium 1 is assumed to be weak enough that the direction of vector $\mathbf{k}_{1,\text{real}}$ and that of vector $\mathbf{k}_{1,\text{imag}}$ are the same. Thus, the angle θ_{1l} is a real angle. The energy ΔQ_{qOl} is described through the time mean $\langle \mathbf{S}_q(\mathbf{r}_O) \rangle$ of the Poynting vector of the wave by,

$$\begin{aligned} \Delta Q_{qOl} &= |\langle \mathbf{S}_q(\mathbf{r}_O) \rangle| \Delta A_{Ol} \\ &= kn_1 |\mathbf{E}_{qOl}|^2 \Delta A_{Ol} / (2\mu\omega) \end{aligned} \quad (19)$$

where μ and ω are absolute magnetic permeability of vacuum and angular frequency of the electromagnetic wave, respectively.

From another point of view, this energy ΔQ_{qOl} of thermally emitted radiation should be characterized by Planck's theory of thermal radiation. The energy ΔQ_{qOl} is emitted in the solid

angle $\Delta\Omega_{OI}$ ($=\Delta A_{OI}/r_O^2$) in the direction of the emission angle θ_{1l} and attenuated by the absorption medium 1. The energy is described by,

$$\Delta Q_{qOI} = \varepsilon_{q21} n_1^2 \frac{I_B}{2} \exp(-2kk_1 r_O) \Delta A_1 \cos \theta_{1l} (\Delta A_{OI}/r_O^2) \quad (20)$$

where I_B is the intensity of blackbody radiation in vacuum. ε_{q21} is the emittance of medium 2 to medium 1 for the q-polarized wave. It depends on temperature. At this stage, two fundamental theories are combined: electromagnetic description of a spherical wave based on the Maxwell's theory of electromagnetism, and radiative heat transfer description of diffuse blackbody radiation based on Planck's theory of thermal radiation. The emittance ε_{q21} is calculated by using Fresnel's complex reflection coefficient by,

$$\varepsilon_{q21} = 1 - |\hat{r}_{q12l}|^2 \quad (21)$$

where Kirchhoff's law is assumed on the reflected and emitted intensity of radiation on the interface II. No assumption on the phase of the emitted spherical wave is adopted here.

From Eqs. (6), (19) and (20) intensity $|E_{qOI}|$ of electric field E_{qOI} in Eq. (8) is written by,

$$\begin{aligned} |E_{qOI}|^2 &= \frac{2\mu\omega}{kn_1} \varepsilon_{q21} n_1^2 \frac{I_B}{2} \exp(-2kk_1 r_O) \Delta A_1 \cos \theta_{1l} \left(\frac{kn_1}{2\pi}\right)^2 \\ &= \frac{1}{(2\pi)^2} 2\mu\omega kn_1 \varepsilon_{q21} n_1^2 \frac{I_B}{2} \exp(-2kk_1 r_O) r_l'^2 \Delta\Omega_{1l} \end{aligned} \quad (22)$$

The magnitude r_l' of vector \mathbf{r}_l' and solid angle $\Delta\Omega_{1l}$ in this equation are described as follows,

$$r_l' = |\mathbf{r}_l'| = (2l+1)d/\cos \theta_{1l} \quad (23)$$

$$\Delta A_1 \cos \theta_{1l} \Delta\Omega_{OI} = \Delta A' \cos \theta_{1l} \Delta\Omega_{1l} \quad (24)$$

$$\Delta\Omega_{OI} = \Delta A_{OI}/r_O^2 = \Delta A' \cos \theta_{1l} / r_l'^2 \quad (25)$$

$$\Delta\Omega_{1l} = \Delta A_1 \cos \theta_{1l} / r_l'^2 \quad (26)$$

3.3.5 Intensity of electric field of multiply interfered wave on film surface The

magnitude of electric field $\hat{E}_0(\mathbf{r}')$ in Eq. (18) is written through Eqs. (12) and (22) by,

$$\begin{aligned} &\|\hat{E}_0(\mathbf{r}')\|^2 \\ &= \frac{(2\pi)^2}{\exp(-2kk_1 r_O)} \|\Sigma_q [\Sigma_l E_{qOI} \hat{g}_{ql}]\|^2 \\ &= \frac{(2\pi)^2}{\exp(-2kk_1 r_O)} \|\Sigma_q [\Sigma_l |E_{qOI}| \mathbf{e}_{ql} \hat{g}_{ql}]\|^2 \end{aligned}$$

$$\begin{aligned}
 &= \frac{(2\pi)^2}{\exp(-2kk_1r_0)} \frac{1}{(2\pi)^2} 2\mu\omega kn_1(n_1^2 \frac{I_B}{2}) \exp(-2kk_1r_0) \|\Sigma_q[\Sigma_l \varepsilon_{q21l}^{1/2} r_l', \Delta\Omega_{1l}^{1/2} \mathbf{e}_{ql} \hat{\mathbf{g}}_{ql}]\|^2 \\
 &= 2\mu\omega kn_1(n_1^2 \frac{I_B}{2}) \|\Sigma_q[\Sigma_l \varepsilon_{q21l}^{1/2} r_l', \Delta\Omega_{1l}^{1/2} \mathbf{e}_{ql} \hat{\mathbf{g}}_{ql}]\|^2
 \end{aligned} \tag{27}$$

3.3.6 Conversion of solid angle accompanied by interface transmission

We deal

with the conversion of the solid angle by the interface transmission of the wave as shown in Figure 4. Solid angle $\Delta\Omega_{1l}$ of the wave incident on interface I through an infinitesimal area $\Delta A'$ and solid angle $\Delta\Omega_{0l}$ after the transmission of interface I, are related to each other, by,

$$\Delta A' \cos\theta_{0l} \Delta\Omega_{0l} = \Delta A' \cos\theta_{0l} \sin\theta_{0l} \Delta\phi \Delta\theta_{0l} \tag{28}$$

$$\Delta A' \cos\theta_{1l} \Delta\Omega_{1l} = \Delta A' \cos\theta_{1l} \sin\theta_{1l} \Delta\phi \Delta\theta_{1l} \tag{29}$$

By using Snell's equations and the differential form for transparent media [7],

$$\sin\theta_{0l} = n_1 \sin\theta_{1l} \tag{30}$$

$$\Delta\theta_{0l} \cos\theta_{0l} = n_1 \Delta\theta_{1l} \cos\theta_{1l} \tag{31}$$

the following equations are obtained.

$$\begin{aligned}
 (\Delta\Omega_{0l} \cos\theta_{0l}) / (\Delta\Omega_{1l} \cos\theta_{1l}) &= \{(\sin\theta_{0l}) / (\sin\theta_{1l})\} \{(\Delta\theta_{0l} \cos\theta_{0l}) / (\Delta\theta_{1l} \cos\theta_{1l})\} \\
 &= n_1^2
 \end{aligned} \tag{32}$$

$$\Delta\Omega_{1l} = (\cos\theta_{0l} / \cos\theta_{1l}) (1/n_1^2) \Delta\Omega_{0l} \tag{33}$$

$$\Delta\Omega_{10} = \Delta A' / (d / \cos\theta_{10})^2 \tag{34}$$

$$\begin{aligned}
 \Delta\Omega_{1l} &= \Delta A' / \{(2l+1)d / \cos\theta_{1l}\}^2 \\
 &= [(d / \cos\theta_{10}) / \{(2l+1)d / \cos\theta_{1l}\}]^2 \Delta\Omega_{10} \\
 &= [\cos\theta_{1l} / \{(2l+1)\cos\theta_{10}\}]^2 (\cos\theta_{00} / \cos\theta_{10}) (1/n_1^2) \Delta\Omega_{00}
 \end{aligned} \tag{35}$$

We notate here symbols $\Delta\Omega_{00}$, θ_{00} and θ_{10} by simplified ones $\Delta\Omega_0$, θ_0 , and θ_1 , respectively.

Thus, solid angle $\Delta\Omega_{1l}$ in Eq. (27) is written by,

$$\Delta\Omega_{1l} = [\cos\theta_{1l} / \{(2l+1)\cos\theta_1\}]^2 (\cos\theta_0 / \cos\theta_1) (1/n_1^2) \Delta\Omega_0 \tag{36}$$

3.3.7 Energy of radiation emitted by film system

The magnitude $|\langle \mathbf{S}_0(\mathbf{r}') \rangle|$ of

time mean of Poynting vector of electric field $\hat{\mathbf{E}}_0(\mathbf{r}')$ in Eq. (18) is written by,

$$|\langle \mathbf{S}_0(\mathbf{r}') \rangle| = \|\hat{\mathbf{E}}_0(\mathbf{r}')\|^2 k \cdot 1 / (2\mu\omega) \tag{37}$$

Radiation energy ΔQ_0 which passes through the infinitesimal area $\Delta A'$ in the vicinity of

position \mathbf{r}' is written by,

$$\begin{aligned}\Delta Q_0 &= |\langle \mathbf{S}_0(\mathbf{r}') \rangle| \Delta A' \cos \theta_0 \\ &= \|\hat{\mathbf{E}}_0(\mathbf{r}')\|^2 k \cdot 1 \cdot \Delta A' \cos \theta_0 / (2\mu\omega)\end{aligned}\quad (38)$$

Accordingly, the energy ΔQ_0 is written through Eqs. (27) and (36) by,

$$\begin{aligned}\Delta Q_0 &= 2\mu\omega k n_1 \left(n_1^2 \frac{I_B}{2}\right) k \cdot 1 \cdot \Delta A' \{\cos \theta_0 / (2\mu\omega)\} \|\Sigma_q[\Sigma_l \varepsilon_{q2l}^{1/2} r_l', \Delta\Omega_{1l}^{1/2} \mathbf{e}_{ql} \hat{\mathbf{g}}_{ql}]\|^2 \\ &= \frac{\cos \theta_0}{\cos \theta_1} k^2 n_1 \frac{I_B}{2} \Delta A' \cos \theta_0 \Delta\Omega_0 \|\Sigma_q[\Sigma_l \varepsilon_{q2l}^{1/2} r_l', \frac{\cos \theta_{1l}}{(2l+1)\cos \theta_1} \mathbf{e}_{ql} \hat{\mathbf{g}}_{ql}]\|^2 \\ &= \frac{\cos \theta_0}{(\cos \theta_1)^3} k^2 n_1 \frac{I_B}{2} \Delta A' \cos \theta_0 \Delta\Omega_0 \|\Sigma_q[\Sigma_l \varepsilon_{q2l}^{1/2} r_l', \frac{\cos \theta_{1l}}{2l+1} \mathbf{e}_{ql} \hat{\mathbf{g}}_{ql}]\|^2\end{aligned}\quad (39)$$

In this equation, only one solid angle $\Delta\Omega_0$, which is equal to the solid angle of observation, is included.

3.3.8 Emittance of film system The energy ΔQ_0 is that the infinitesimal area $\Delta A'$ on interface I of the film system emits in the solid angle $\Delta\Omega_0$ and in the direction of emission angle θ_0 . Let's consider the case when a blackbody of infinitesimal area $\Delta A'$ is put at the same point O. Radiation energy ΔQ_{B0} emitted by the blackbody in the solid angle $\Delta\Omega_0$ and in the emission angle θ_0 is written by,

$$\Delta Q_{B0} = I_B \Delta A' \cos \theta_0 \Delta\Omega_0 \quad (40)$$

From Eqs. (39) and (40), (spectral directional) emittance $\varepsilon_{(s+p), \text{film}}$ of the film system for natural radiation emission is written as follows,

$$\begin{aligned}\varepsilon_{(s+p), \text{film}} &= \Delta Q_0 / \Delta Q_{B0} \\ &= \frac{\cos \theta_0}{(\cos \theta_1)^3} k^2 n_1 (1/2) \|\Sigma_q[\Sigma_l \varepsilon_{q2l}^{1/2} r_l', \frac{\cos \theta_{1l}}{2l+1} \mathbf{e}_{ql} \hat{\mathbf{g}}_{ql}]\|^2\end{aligned}\quad (41)$$

Since the vectors \mathbf{e}_{sl} and \mathbf{e}_{pl} cross orthogonally and $(\Sigma_l \mathbf{e}_{sl})$ and $(\Sigma_l \mathbf{e}_{pl})$ cross orthogonally, emittance $\varepsilon_{q, \text{film}}$ for s- and p-polarized components of radiation is written by the following equation,

$$\varepsilon_{q, \text{film}} = \frac{\cos \theta_0}{(\cos \theta_1)^3} k^2 n_1 \|\Sigma_l \varepsilon_{q2l}^{1/2} r_l', \frac{\cos \theta_{1l}}{2l+1} \mathbf{e}_{ql} \hat{\mathbf{g}}_{ql}\|^2 \quad (42)$$

Equation (39) for the emitted radiation energy ΔQ_0 includes I_B given by Planck's theory.

On the other hand, in Eqs. (41) and (42) for emittances $\varepsilon_{(s+p), \text{film}}$ and $\varepsilon_{q, \text{film}}$, I_B does not

appear. The emittance depends on temperature through the temperature dependence of the optical constant of medium 2 (substrate of the film system).

3.4 Procedure of calculation

In order to compare the emittance calculated by the proposed model with the measured emittance $\varepsilon_N^{\text{exp}}(600 \text{ K})$, we calculate on a film system at $T=600 \text{ K}$ in which a film of $d=0.9 \mu\text{m}$ in thickness is formed on a nickel substrate. The spectrum of optical constant \hat{n}_2 of the substrate is calculated as functions of wavelength λ of radiation and temperature T , by a technique given in Reference [8]. The optical constant of the film is set at $n_1=2.0$ and $k_1=0.01$ independently of wavelength and temperature. The angle of observation of the emitted radiation is set at $\theta_0=15^\circ$. Emittances $\varepsilon_{(s+p), \text{ film}}$, $\varepsilon_{s, \text{ film}}$ and $\varepsilon_{p, \text{ film}}$ in the wavelength region $\lambda=0.7\sim 20 \mu\text{m}$ are calculated. Multiple reflection in the film is calculated on $l=0, 1, 2, \dots, 10$. The position vector \mathbf{r}_l' is described by,

$$\mathbf{r}_l'=(d\sin\theta_l, 0, d\cos\theta_l) \quad (43)$$

Constants and variables in Eqs. (41) and (42) are calculated by Eqs. (4), (5), (9), (10), (11), (13), (14), (16), (21), (23) and (43), and by Snell's equations and Fresnel's equations for the reflection and refraction at interfaces I and II. In the calculation of Fresnel's complex reflection and transmission coefficients for interface I, the optical constant of the film and the reflection and refraction angles at interface I are dealt as real quantities for considering the weak absorption of medium 1.

3.5 Reflectance of film system

For the comparison in Sections 4 and 5 on measured and calculated values and on reflection and emission values, we calculate the reflectance R_{NN} by conventional equations [9], on the case when a plane electromagnetic wave is incident on a film system of Section 3.4 and reflected specularly.

4. Calculated Results and Comparison with Measured Results

4.1 Results of spectrum calculation

Figure 5 summarizes calculated results of spectra of reflectance R_{NN} and emittance ε_N of the film system with the measured results. Results of reflectance R_{NN} for the natural radiation, that for the s-polarized component and that for the p-polarized component are, respectively, the spectra of reflectances $R_{NN(s+p)}^{\text{calc}}$, R_{NNs}^{calc} and R_{NNp}^{calc} in the figure. Results of emittance ε_N for the natural radiation, that for the s-polarized component and that for the p-polarized component are, respectively, the spectra of emittances $\varepsilon_{N(s+p)}^{\text{calc}} (= \varepsilon_{(s+p), \text{film}})$, $\varepsilon_{Ns}^{\text{calc}} (= \varepsilon_{s, \text{film}})$ and $\varepsilon_{Np}^{\text{calc}} (= \varepsilon_{p, \text{film}})$ in the figure. Difference of $R_{NN(s+p)}^{\text{calc}}$, R_{NNs}^{calc} and R_{NNp}^{calc} and that of $\varepsilon_{N(s+p)}^{\text{calc}}$, $\varepsilon_{Ns}^{\text{calc}}$ and $\varepsilon_{Np}^{\text{calc}}$ are small. Figure 5 also shows the spectra of reflectance $R_{NN}^{\text{calc}}(\text{specular})$ and emittance $\varepsilon_N^{\text{calc}}(\text{specular})$ of the bare optically smooth nickel surface for comparison.

4.2 Calculated values of reflectance and emittance

The calculated reflectance is for the plane wave, and the emittance is for the spherical wave. In spite of this difference, wavelengths of the valleys and hills of the oscillation in the calculated spectra of reflectance R_{NN}^{calc} , and those of hills and valleys of the oscillation in the calculated spectra of emittance $\varepsilon_N^{\text{calc}}$ are, respectively, near to each other. In this calculation on a flat and smooth film system the directional reflectance R_{NN} is equal to the hemispherical reflectance R_{NH} . If we assume that Kirchhoff's law for thermal equilibrium systems is valid, then the following complementary relationship,

$$R_{NN}^{\text{calc}} + \varepsilon_N^{\text{calc}} = R_{NH}^{\text{calc}} + \varepsilon_N^{\text{calc}} = 1 \quad (44)$$

holds between reflectance R_{NN}^{calc} and emittance $\varepsilon_N^{\text{calc}}$. This quantitative relationship seems to hold except for the calculated values of R_{NN}^{calc} and $\varepsilon_N^{\text{calc}}$ in the wavelength regions of interference hills in the $\varepsilon_N^{\text{calc}}$ spectrum. In the wavelength regions of interference hills in the

$\varepsilon_N^{\text{calc}}$ spectrum, the height of the hills in the emittance spectrum is smaller than the depth of the valleys in the $R_{\text{NN}}^{\text{calc}}$ spectrum.

4.3 Calculated and measured values of reflectance and emittance

We compare the calculated and measured spectra of reflectance and emittance. Since the influence of surface roughness of the film system is neglected in the calculation, values of reflectance $R_{\text{NN}}^{\text{calc}}$ are calculated higher than the measured values of $R_{\text{NN}}^{\text{exp}}$ in the shorter wavelength region where the influence of surface scattering on the directional reflectance $R_{\text{NN}}^{\text{exp}}$ is stronger. Since the emittance increase by surface roughness in the surface system of the experiment is not considered in the calculation, values of emittance $\varepsilon_N^{\text{calc}}$ are lower than those of $\varepsilon_N^{\text{exp}}$ particularly in the shorter wavelength region. Also, since self-emission of the film is neglected in the calculation, the values of the calculated emittance $\varepsilon_N^{\text{calc}}$ are lower. But, with respect to the radiation interference, the wavelengths of interference in the calculated spectra of $R_{\text{NN}}^{\text{calc}}$ and $\varepsilon_N^{\text{calc}}$ agree well with those in the measured spectra of $R_{\text{NN}}^{\text{exp}}$ and $\varepsilon_N^{\text{exp}}$. The hills of interference in the calculated spectrum of $\varepsilon_N^{\text{calc}}$ are less sharp than the hills of interference in the measured spectrum of $\varepsilon_N^{\text{exp}}$.

5. Interference of Emitted Thermal Radiation

5.1 Wavelength of interference and phase of spherical wave

Interference in an emittance spectrum for a spherical wave is different from that in a reflectance spectrum for a plane wave. The interference occurs as a result of multiple reflection in the film system. The spherical wave propagates over various directions. This fact may imply that the wavelengths of interference depend on the direction of observation, and that the emittance spectrum lacks the sharpness in the spectrum oscillation. But, it is not the case in the measured results in Figure 5. It is explained by the following facts. The refractive

index of the film is of an order of $n_1=2$, and the radiation in the direction of emission angle of 15° , the angle of observation in the present study, is the interfered components of spherical waves emitted by a dipole on interface II of the film system and propagates in the direction of $\theta_l < 7.4^\circ$ in the film. That is, direction, phase and wavelength of the interference of the observed emission wave are not so much different from those in the case of the reflection of the plane wave.

5.2 Sharpness and amplitude of spectrum oscillation

The amplitude of interference oscillations in the calculated emittance spectrum is not so sharp as that in the calculated reflectance spectrum. The following should be noticed. The interference of the wave in the film system occurs mainly among the 0th-order wave ($l=0$) and the 1st-order wave ($l=1$). In a weakly absorbing medium, intensity of a spherical wave is attenuated inversely proportional to the square of the distance from the radiation source. The intensity of the 1st-order wave decreases in the film to be $1/9$ of that of the 0th-order wave. Equivalent interference of the 1st- and 0th-order waves, as is the case in the film reflection of plane waves, can not be realized in the case of emitted spherical waves. Therefore interference in the calculated emittance spectrum is far less clear than that in the calculated reflectance spectrum.

5.3 Interference of radiation emitted by a number of dipoles

The present theoretical model describes the interference of the emitted thermal radiation qualitatively well. But, the spectrum oscillation in the calculated emittance spectrum is less sharp than that in the measured emittance spectrum, and the values of the calculated emittance are lower than those of the measured emittance. Since the roughness of the surface of the experiment influences the measured spectrum to round the interference effect in the oscillating spectra and to increase the values of emittance inversely, it cannot be the origin of the deviation of the calculated and measured emission spectra. With respect to the sharpness

of the spectrum oscillation, the measured emittance spectrum is rather near to the measured reflectance spectrum. This point is important in considering the validity of the model proposed in Section 3. Considering the discussion in Sections 4.3 and 5.2, the deviation in calculated and measured emission spectra may be caused by the assumption in Section 3.1 on the incoherency of the emitted radiation wave by a number of dipoles in the metal substrate.

In the present film system the radiation sources of the dipole emission are conduction electrons of a metal. Thermal movement of a number of conduction electrons might not be independent among each other, but the electromagnetic fields of the emitting dipoles might interact with each other. Electromagnetic waves of thermal radiation emitted by a number of dipoles in the metal might be coherent among each other. If it is the case, the electromagnetic field of multiple reflection of the spherical waves in the film system which emits thermal radiation may be similar to the field of multiple reflection of the plane waves of the reflection. Theoretical calculation on such a model of coherent dipole emission sources would estimate that the interference of the waves of $l=0$ and $l=1, 2, 3, \dots$ can be similar to that in the case of reflection of a plane wave, and the interference in the emittance spectrum as sharp as that in the measured spectrum.

5.4 Spectrally functional emitter of thermal radiation

In the measured emittance spectra in Figure 5, emittance is high in the longer interference hill wavelength region. The present film system emits the radiation of the wavelength band region selectively. On the other hand, radiation energy in the shorter wavelength side less than $\lambda = 2 \mu\text{m}$ is weak for the sake of Planck's distribution at the temperature of a 600 K level irrespective of the higher emittance values in the shorter wavelength region. That is, the spectral function of the present film system is excellent. The wavelength of interference of the film system is easily controlled in the film formation process as shown in Figure 1. The film system can be produced easily over a wide surface area of an order of m^2 . The present film system is prospective for a radiation emitter for the

new thermal energy engineering.

6. Concluding Remarks

In the present study, a spectroscopic experiment and a model calculation of electromagnetism have been made on a spherical wave of thermal radiation emitted by a film system which consists of a metal substrate and a semi-transparent film. The following conclusions have been made:

- (1) It has been reconfirmed experimentally that thermal radiation emitted by this film system is characterized by a clear interference phenomenon.
- (2) A theoretical model has been presented to describe the interference in thermal radiation emission of this film system. In the model an electromagnetic theory for a spherical wave is combined with Planck's theory of thermal radiation.
- (3) It has been suggested that thermal radiation waves emitted by a number of dipoles of a metal might be coherent among each other.
- (4) This film system is prospective as a spectrally functional emitter of radiation which emits radiation in a specified wavelength band region selectively.

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References

- [1] Wakabayashi, H. and Makino, T., A New Spectrophotometer System for Measuring Thermal Radiation Phenomena in a 0.30-11 μm Wavelength Region, *Measurement Science and Technology*, vol. 12, no. 12 (2001), pp. 2113-2120.
- [2] Makino, T., Thermal Radiation Spectroscopy for Heat Transfer Science and for Engineering Surface Diagnosis, "*Heat Transfer 2002*", vol.1, (2002), pp. 55-66, Taine, J. ed., Elsevier, Paris.
- [3] Iuchi, T. and Furukawa, T., Emissivity- Compensated Radiation Thermometry, *Proceedings of IMEKO 2000 International Measurement Confederation 16th IMEKO World Congress*, vol. 6, (2000), pp. 365-369.
- [4] Hanamura, K. and Kumano, T., Thermophotovoltaic Power Generation by Super-Adiabatic Combustion in Porous Quartz, *Thermal Science and Engineering*, vol. 10, no. 4 (2002), pp. 9-10.
- [5] Makino, T. and Wakabayashi, H., Thermal Radiation Spectroscopy Diagnosis for Temperature and Microstructure of Surfaces, *JSME International Journal*, ser.B, vol. 46, no. 11 (2003), pp.500-509.
- [6] Makino, T., Wakabayashi, H. and Matsumoto, M., Interference of Spherical Wave of Thermal Radiation Emitted by a Film System and a Grating System, *Proceedings of the First International Forum on Heat Transfer*, (2004), pp.185-186.
- [7] Brewster, M. Q., "*Thermal Radiative Transfer and Properties*", (1992), pp. 114-156, John Wiley & Sons, New York.
- [8] Makino, T., Wakabayashi, H. and Matsumoto, M., Interference of Spherical Wave of Thermal Radiation Emitted by a Film System and a Grating System, *Proceedings of the First International Forum on Heat Transfer*, (2004), pp.185-186.
- [9] Heaven, O. S., "*Optical Properties of Thin Solid Films*", (1965), pp. 46-95, Dover Pub.

Inc., New York.

Figure Captions

- Figure 1 Spectrum transition of reflectance R_{NN} and emittance ε_N of a nickel surface in a film formation process
- Figure 2 Interference of thermal radiation emitted by a film system
- Figure 3 Physical model of a film system
- Figure 4 Conversion of solid angles for the l -th spherical wave
- Figure 5 Spectra of reflectance R_{NN} and emittance ε_N of the film system (measured and calculated)

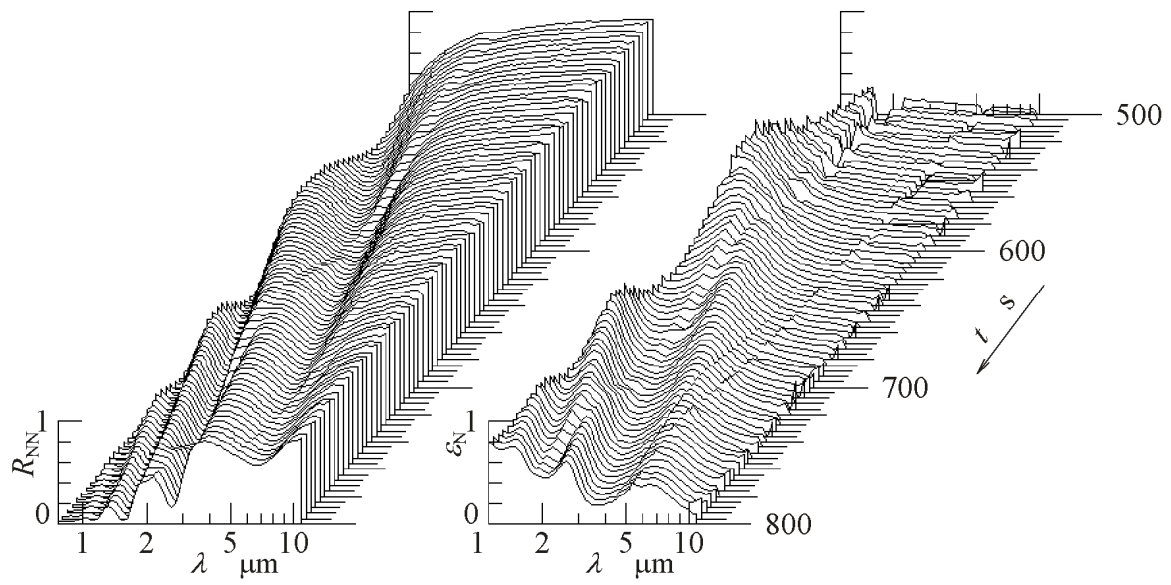


Figure 1 Spectrum transition of reflectance R_{NN} and emittance ϵ_N of a nickel surface in a film formation process

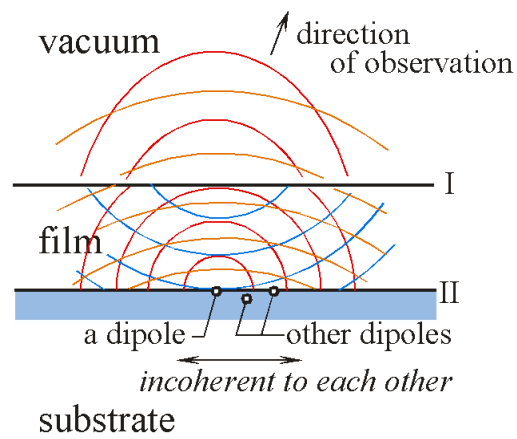


Figure 2 Interference of thermal radiation emitted by a film system

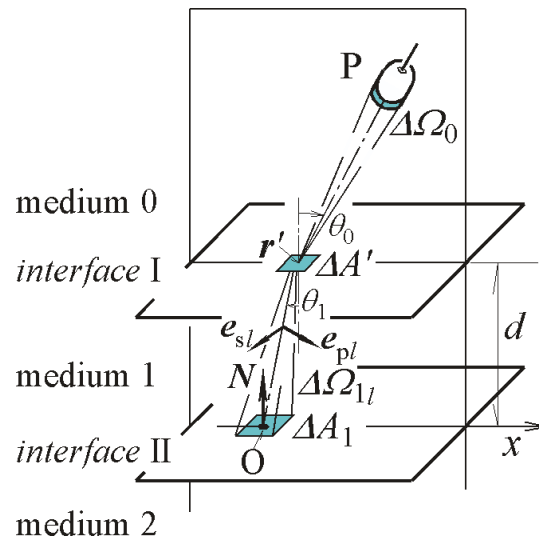


Figure 3 Physical model of a film system

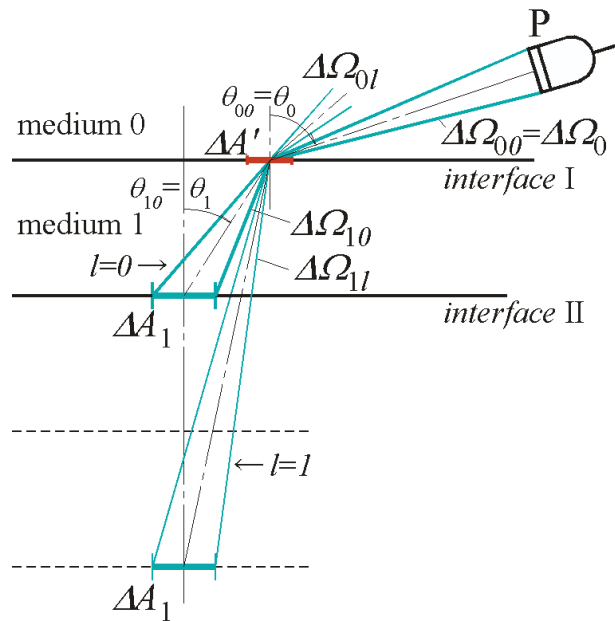


Figure 4 Conversion of solid angles for the l -th spherical wave

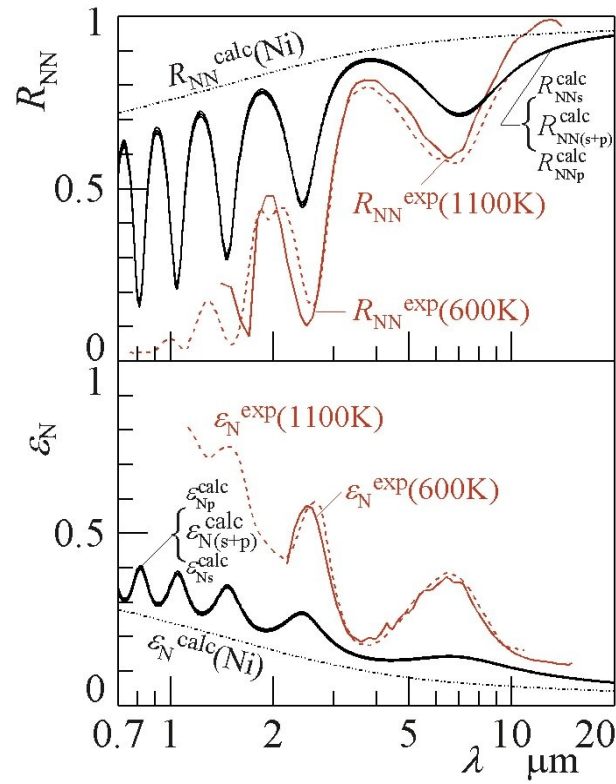


Figure 5 Spectra of reflectance R_{NN} and emittance ε_N of the film system (measured and calculated)